

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Shoriki NARITA et al. :
Serial No. NEW : **Attn: APPLICATION BRANCH**
Filed August 29, 2003 : Attorney Docket No. 2003_1226

BUMP FORMING APPARATUS FOR
CHARGE APPEARANCE SEMICONDUCTOR
SUBSTRATE, CHARGE REMOVAL
METHOD FOR CHARGE APPEARANCE
SEMICONDUCTOR SUBSTRATE,
CHARGE REMOVING UNIT FOR
CHARGE APPEARANCE SEMICONDUCTOR
SUBSTRATE, AND CHARGE APPEARANCE
SEMICONDUCTOR SUBSTRATE

(Rule 1.53(b) Divisional
of Serial No. 10/019,700,
Filed January 2, 2002)

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to initial examination, kindly amend the application as follows: